## Photolysis Studies Using Synchrotron Radiation: CFCl<sub>3</sub>/Si(111) 7x7

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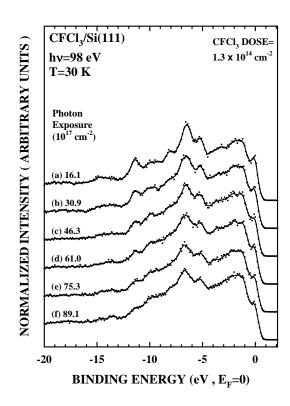
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The photolysis of CFCl<sub>3</sub> adsorbed on Si(111)-7×7 surface at 30 K by 98-eV synchrotron radiation was studied by using photoelectron spectroscopy (PES). The photoemission data was collected using synchrotron radiation at NSRRC LSGM beam line. In the present work, the surface was studied for the soft x-ray-induced photochemical using reactions valence-level photoemission spectroscopy. The surface was prepaired by exposure of a clean Si(111)-7x7 surface to  $1.3x10^{14}$ molecules/cm<sup>2</sup> of CFCl<sub>3</sub> at 30 K. A series of photoemission spectra was taken in time during continual irradiation of monochromatic photons (98 eV) until little visual difference was observed in the two most recent spectra. These series of photoemission spectra (Fig. 1 and Fig. 2) indicate that there is a dramatic change in the

CFCl<sub>3</sub>/Si(111) CFCl, DOSE= NORMALIZED INTENSITY (ARBITRARY UNITS 1.3 x 10<sup>14</sup> cm<sup>-2</sup> hv=98 eV T=30 K Photon Exposure  $(10^{17} \text{ cm}^{-2})$ (a) 1.1 (b) 3.5 (c) 6.6 (d) 9.8 (e) 12.9 (f) 16.1 -20 -15 -10 -5 BINDING ENERGY (eV ,  $E_F=0$ )

**Figure 1.** Series of valence-level photoelectron spectra of CFCl<sub>3</sub> adsorbed on Si(111)-7x7 at 30 K as a function of photon exposure using 98 eV photons. The CFCl<sub>3</sub> dose of the surface is  $1.3 \times 10^{14}$  molecules/cm<sup>2</sup>. The total photon exposure for each spectrum is given in units of  $10^{17}$  photons/cm<sup>2</sup> and shown on the left of the figure.

spectra as a result of exposure to the photon beam. The intensities of all peaks decrease and their relative intensities also change. These changes are not a result of contamination, as subsequent PES of an area of the sample that had not been previously exposed to the photon beam resulted in a spectrum that was identical to the top spectrum in Fig. 1. The changes observed in Fig. 1 and 2 are the result of photolysis of the CFCl<sub>3</sub> surface complex due to exposure to the 98 eV photons from the synchrotron radiation source, which indicates a high cross section. A kinetic model was proposed for the explanation of the photolysis of the CFCl<sub>3</sub>-dosed surface induced by the incident photons, and the variation of the spectrum shape of these two spectra.



**Figure 2.** Series of valence-level photoelectron spectra (which extends the series of Fig. 1) of CFCl<sub>3</sub> adsorbed on Si(111)-7x7 at 30 K as a function of photon exposure using 98 eV photons. The CFCl<sub>3</sub> dose of the surface is  $1.3 \times 10^{14}$  molecules/cm<sup>2</sup>. The total photon exposure for each spectrum is given in units of  $10^{17}$  photons/cm<sup>2</sup> and shown on the left of the figure.